



00862.0022167

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Shinichi HARA et al.

Application No.: 09/818,625 ✓

Filed: March 28, 2001

For: EXPOSURE APPARATUS, GAS REPLACEMENT  
METHOD, SEMICONDUCTOR DEVICE  
MANUFACTURING METHOD, SEMICONDUCTOR  
MANUFACTURING FACTORY, AND EXPOSURE  
APPARATUS MAINTENANCE METHOD

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: Examiner: D. Ben Esplin  
)  
: Group Art Unit: 2851  
)  
: Confirmation No.: 1693  
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:  
) October 9, 2003  
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**Mail Stop Issue Fee**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

REQUEST FOR NOTICE OF PUBLICATION

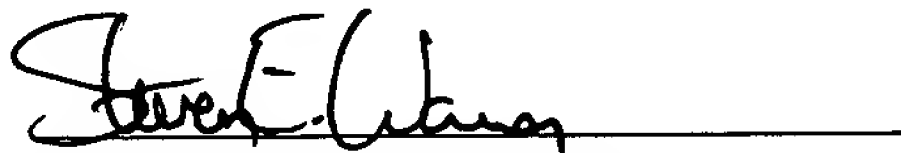
Sir:

To date, Applicants have not received a Notice of Publication and publication number for the above-identified application. Accordingly, Applicants request that a Notice of Publication be issued to provide Applicant with a publication number and date of publication for this application.

Applicants believe that no fees should be incurred in connection with filing this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fees be associated therewith. A duplicate of this document is enclosed for this purpose.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our below-listed address.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Steven E. Warner", is written over a horizontal line.

Attorney for Applicants

Steven E. Warner

Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3801  
Facsimile: (212) 218-2200  
SEW/eab